

Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 245402008300	Application Number Not Yet Assigned
Applicant	Nobuaki TERAGUCHI
Filing Date Concurrently Herewith	Group Art Unit Not Yet Assigned
Mailing Date February 3, 2004	

## U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate

## FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
10	1.	05/11/1993	JP 5-291621	Japan			Abstract

## OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
10	2.	Ruvimov, S. et al. (1998). "Microstructure of Ti/Al Ohmic Contacts for n-AlGaN," <i>Appl. Phys. Lett.</i> 73(18):2582-2584.

EXAMINER:

Netra Parekh

DATE CONSIDERED: 04/20/05

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.